

IDS Form PTO/SB/08: Substitute for form 1449A/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/642,680 ✓	
			Filing Date	August 19, 2003 ✓	
			First Named Inventor	Ryouichi INANAMI ✓	
			Art Unit	3661 ✓ 2825	
			Examiner Name	Unknown- LIN SUN J JUN 27 2005	
Sheet	1	of	1	Attorney Docket Number	04329.3115

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-			
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Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
JSA		JP 2001-257145	09/21/2001			No

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
JSA		Copy of "Notification of Reasons for Rejection," issued by the Japanese Patent Office on April 26, 2005 in counterpart Application No. 2002-238198 and its English translation	Yes

Examiner Signature	<i>James Sun Bin</i>	Date Considered	7-31-05
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION

OMB No. 0651-0011

9-19-03

Atty. Docket No. 04329.3115	Serial No. Not Yet Assigned 10/642,680
Applicants Ryouichi INANAMI et al.	
Filing Date August 19, 2003	Group: Not Yet Assigned 2825

U.S. PATENT DOCUMENTS							
Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS							
		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
JSR		2002-151383	05/24/02	JAPAN	—	—	ABSTRACT
JSR		10-303126	11/13/98	JAPAN	—	—	ABSTRACT

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
JSR	INANAMI, R. et al., "Charged Particle Beam Exposure Method And Method For Producing Charged Particle Beam Exposure Data", U.S. Application No. 10/255,830, filed September 27, 2002.
JSR	INANAMI, R. et al., "Exposure Pattern Data Generation Apparatus Associated With Standard Cell Library And Charged Beam Exposure", U.S. Application No. 09/817,270, filed March 27, 2001.

Examiner <i>James P. Smith</i>	Date Considered 7-31-05
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	
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